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## I CLAIM:

A method for fabricating a leadframe structure comprising a chip mount pad and a plurality of lead segments, each having a first end near said mount pad and a second end remote from said mount pad, comprising the steps of:

> forming said structure from a sheet-like starting material;

plating a layer of nickel on said leadframe; selectively masking said second segment ends, thereby leaving said chip pad and said first segment ends exposed;

- selectively plating a layer of palladium on said nickel layer on said exposed chip pad and segment ends in a thickness suitable for bonding wire attachment;
- selectively masking said chip pad and said first segment ends, thereby leaving said second segment ends exposed; and
- selectively plating a layer of tin onto said nickel layer on said exposed segment ends in a thickness suitable for parts attachment.
- The method according to Claim 1 wherein said plating of 2. said nickel layer and said plating of said selective 25 palladium layer are performed in a first plating system providing for said palladium plating a wheel with apertures defining said selective locations.
- The method according to Claim 1 wherein said plating of said tin layer is performed in a second plating system 30 providing photo-imagible or printable plating masks.
  - The method according to Claim 3 wherein said second

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plating system provides:
 coating with a plating resist;
 photoimaging;
 developing said resist;

 plating with tin;
 stripping said resist;
 rinsing; and
 drying.

5. A method for fabricating a leadframe comprising the steps of:

stamping from a sheet-like copper or copper alloy starting material a leadframe having a mount pad for an integrated circuit chip and a plurality of lead segments having their first end near said mount pad and their second end remote from said mount pad;

in a first plating system, cleaning said leadframe
 in alkaline soak cleaning and alkaline
 electrocleaning;

activating said leadframe by immersing said leadframe into an acid solution, thereby dissolving any copper oxide;

immersing said leadframe into a first electrolytic nickel plating solution and depositing a first layer of nickel onto said copper, thereby fully encasing said copper;

immersing said leadframe into a second electrolytic nickel plating solution and depositing a second layer of nickel onto said first nickel layer, thereby adapting said second ends of said lead segments for mechanical bending and solder attachment;

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selectively masking said second segment ends
thereby leaving, through apertures in said wheel,
said chip pad and said first segment ends
exposed;

- immersing said leadframe into an electrolytic palladium plating solution and depositing a layer of palladium onto said exposed segment ends in a thickness suitable for bonding wire attachment:
- in a second plating system, selectively masking said chip pad and said first segment ends, thereby leaving said second segment ends exposed, said masking provided by photoresist coating, photoimaging, and resist developing;
  - immersing said leadframe into a tin flood cell plating solution and depositing a layer of tin onto said exposed second segment ends in a thickness suitable for parts attachment; and stripping said photoresist, rinsing and drying.
- 20 6. The method according to Claim 5 wherein said first plating system is a wheel-based system, and said second plating system is a flood cell system.
  - 7. The method according to Claim 5 wherein the process steps are executed in sequence without time delays, yet including intermediate rinsing steps.
  - 8. The method according to Claim 5 wherein said acid solution may be sulfuric acid, hydrochloric acid or any other acid.
- 9. The method according to Claim 5 wherein said
  30 photoimaging of said photoresist uses a wheel with
  apertures defining the exposed area of said resist.